

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q85660

Heiji WATANABE, et al.

Appln. No.: 10/521,311

Group Art Unit: 2812

Confirmation No.: 1690

Examiner: Kyoung LEE

Filed: January 14, 2005

For: SEMICONDUCTOR DEVICE, AND MANUFACTURING METHOD AND
MANUFACTURING APPARATUS OF THE SAME

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 6, 2007, please amend the above-identified application as follows on the accompanying pages.

TABLE OF CONTENTS

AMENDMENTS TO THE SPECIFICATION	2
AMENDMENTS TO THE CLAIMS	3
REMARKS	13